



[10191/2169]

1765

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : BECKER et al. Confirmation No.: 8531
Serial No. : 10/031,842
Filed : June 10, 2002
For : DEVICE AND METHOD FOR ETCHING A SUBSTRATE
BY USING AN INDUCTIVELY COUPLED PLASMA
Examiner : S. Ahmed
Art Unit : 1765
Customer No. : 26646

I hereby certify that this correspondence is being deposited with
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Date 11/24/03Atty's Reg. # 41,172

Atty's Signature


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KENYON & KENYON

Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
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ELECTION TRANSMITTAL

SIR:

Please find herewith an Election With Traverse for filing in the
above-identified patent application.

No fee is believed to be required. However, if any fee is required, please
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enclosed for that purpose.

Respectfully submitted,

KENYON & KENYON

By: Richard L. Mayer (Reg. No. 41,172)By: Richard L. MayerRichard L. Mayer
(Reg. No. 22,490)Dated: 11/24/03

One Broadway
New York, New York 10004
(212) 425-7200

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